

Express Mail Label No. EV 325 215 990 US

Express Mail Label No. E 020 210 950 3		
<b>FORM PTO-1449</b>	Docket Number (Optional) 81788.0251	Application Number Not Assigned; Parent 10/281,852
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>	Applicant	FURUKAWA, et al.
(Use several sheets if necessary)	Filing Date June 23, 2003	Group Art Unit Not Assigned

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2000-082849	03/21/00	JAPAN				
	11-087778	03/30/99	JAPAN				
	10-012916	01/16/98	JAPAN				

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

Thick GzN Epitaxial Growth with Low Dislocation Density by Hydride Vapor Phase Epitaxy – USUI, et al./ Japanese Journal of Applied Physics 36, Part 2, No. 7B, L899 (1997)

EXAMINER <i>G. M. P.</i>	DATE CONSIDERED <i>12/14/03</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	